IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NOBUYUKI YAMAUCHI, ET AL.))
Serial No) Art Unit: To Be Assigned)
Filed: CONCURRENTLY HEREWITH) Examiner: To Be Assigned)
For: INFORMATION PROCESSING APPARATUS DEFECT ANALYSIS PROGRAM, DEFECT ANALYSIS METHOD, AND APPLICATION PROCESSING APPARATUS)))
PROGRAM DEVELOPMENT ASSISTANCE SYSTEM)

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, DC 20231 Sir:

The citation of information on the attached Form PTO-1449, "List of Art Cited by Applicant" is made pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98. A copy of each cited item is enclosed.

A separate sheet containing a concise explanation of the relevance of each cited document is enclosed as part of this IDS.

The citation of this information does not constitute an admission of priority or that any cited item is available as a reference, or a waiver of any right the applicant may have under applicable statutes, Rules of Practice in patent cases, or otherwise.

Respectfully submitted,

Roger T. Frost

Reg. No. 22,176

KILPATRICK STOCKTON LLP 2400 Monarch Tower 3424 Peachtree Road, N.E. Atlanta, Georgia 30326 (404) 949-3999

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